

10-2-01
PATENT

J1033 U.S. PTO

09/829161

04/09/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Salman Akram

Serial No.: Not yet assigned

Filed: April 9, 2001

For: METALLIZATION STRUCTURES
FOR SEMICONDUCTOR DEVICE
INTERCONNECTS, METHODS FOR
MAKING SAME, AND
SEMICONDUCTOR DEVICES
INCLUDING SAME

Examiner: Unknown

Group Art Unit: Unknown

Attorney Docket No.: 3442.1US (96-428.1)

NOTICE OF EXPRESS MAILING

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INFORMATION DISCLOSURE STATEMENT

Box PATENT APPLICATION
Commissioner for Patents
Washington, D.C. 20231

Sir:

The present application is a divisional of application Serial No. 09/388,031, filed September 1, 1999, pending.

Pursuant to M.P.E.P. 2001.06(b), the Examiner is respectfully requested to consider the information of record in the prior application, and to confirm in the first Office Action on the

merits that such art has in fact been reviewed. A PTO-1449 form listing all of the information of record in the prior application is enclosed herewith.

This Information Disclosure Statement is filed within three (3) months of the filing date of the above-identified application, and no certification pursuant to 37 C.F.R. § 1.97(c) or a fee pursuant to 37 C.F.R. 1.17(p) is required.

Respectfully submitted,



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Date: April 9, 2001
KWP/jml
Enclosure: Form PTO-1449

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